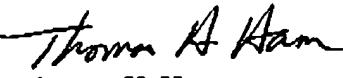


MAY 19 2006

AMENDMENT TRANSMITTAL LETTER Under Small Entity Status				Attorney Docket No: INK-002		
Application Serial Number: 10/829,593		Filing Date: 04/21/2004		Examiner: Rachuba, Maurina T.		Group Art Unit: 3723
Invention: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR WAFERS USING ONE OR MORE POLISHING SURFACES						
TO THE COMMISSIONER OF PATENTS AND TRADEMARKS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	NO. OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	113	MINUS	113	0	\$25	\$ 0.00
INDEP. CLAIMS	11	MINUS	11	0	\$100	\$ 0.00
<p>Petition is hereby made under 37 CFR 1.136(a) to extend the time for response to the Office Action  <input type="text"/> to and through <input type="text"/>, comprising an extension of the shortened statutory period of:</p> <p><input type="text"/> one month (\$60)      <input type="text"/> three months (\$510)  <input type="text"/> two months (\$225)      <input type="text"/> four months (\$795)</p>						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0.00
<p><input type="text"/> Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted.</p> <p><input type="text"/> A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed.</p> <p><input type="text"/> A check in the amount of \$ <input type="text"/> is attached.</p> <p><input type="text"/> Charge \$ <input type="text"/> to Deposit Account <input type="text"/>.</p> <p><input checked="" type="text"/> No additional fee is required.</p>						
<u>May 19, 2006</u> Date		 Thomas H. Ham Reg. No. 43,654				
CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8						
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on May 19, 2006.						
Number of Pages: <u>5</u> (including TRANSMITTAL LETTER)						
 Thomas H. Ham						

Attorney Docket No. INK-002

PATENT APPLICATION

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): In Kwon Jeong

Group Art Unit: 3723

Serial No. 10/829,593

Confirmation No. 6718

Filed: April 21, 2004

Examiner: Rachuba, Maurina T.

For: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR  
WAFERS USING ONE OR MORE POLISHING SURFACES

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Sir/Madam:

In response to the Final Office Action mailed on March 31, 2006, please consider the following **Remarks**, which begin on page 2 of this paper.

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CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8  
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on May 19, 2006.

Number of Pages: 5 (including TRANSMITTAL LETTER)

Signed: Thomas H. Ham  
Typed Name: Thomas H. Ham